

Study of HF Production in BaBar Resistive Plate Chambers

H. R. Band^a, F. Bellini^{b,1}, R. Covarelli^c, E. Di Marco^b,
A. D'Orazio^d, F. Ferroni^b, L. Li Gioi^b, L. Lopez^e, F. Polci^b

^a*University of Wisconsin, Madison, WI, USA*

^b*Università di Roma La Sapienza, Dipartimento di Fisica and INFN, I-00185
Roma, Italy*

^c*Università di Perugia, Dipartimento di Fisica and INFN, I-06100 Perugia, Italy*

^d*Laboratoire de l'Accélérateur Linéar, IN2P3/CNRS et Université Paris-Sud 11,
Centre Scientifique d'Orsay, B. P. 34, F-91898 ORSAY Cedex, France*

^e*Università di Bari, Dipartimento di Fisica and INFN, I-70126 Bari, Italy*

Abstract

The BaBar detector has operated over 200 2nd generation Resistive Plate Chambers (RPCs) in the forward endcap since 2002. Many chambers have increased noise rates and high voltage currents. These aging symptoms are correlated with the integrated RPC current as expected, but also depend on the rate and direction of the gas flow, indicating that pollutants produced in the gas can accelerate aging of downstream RPC surfaces. HF produced by decomposition of the Freon 134a component of the BaBar RPC gas in electric discharges has been proposed as the main pollutant. This paper presents measurements of HF production and absorption rates in BaBar RPCs. Since many of the highest rate chambers in the forward endcap were converted to avalanche mode operation, a comparison of HF production in streamer and avalanche mode RPCs is made. Correlations between the HF production rate and other chamber operating conditions were also explored.

Key words: Resistive Plate Chamber, Muon detection, BaBar, Fluorine

PACS: 29.40.C

¹ Corresponding author. Tel. 0039 0649914338, e-mail Fabio.Bellini@roma1.infn.it.

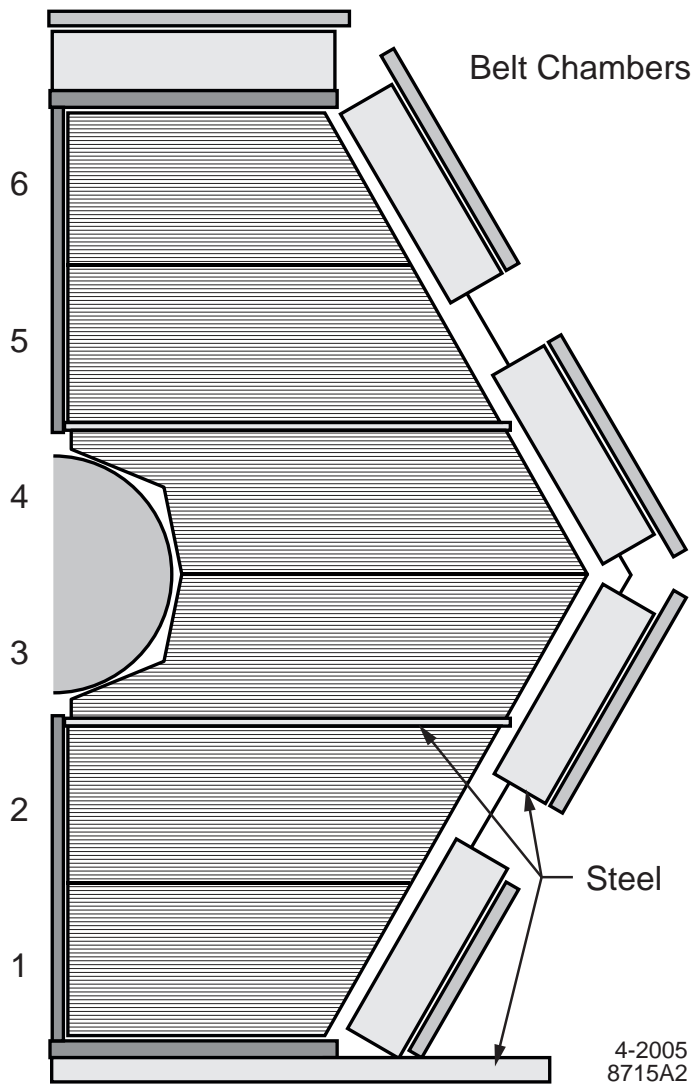


Fig. 1. Typical RPC geometry for a layer in the East door. Each layer contains three chambers. Each chamber is made by two high-voltage modules. The gas lines of the two modules (1-2, 3-4, 5-6) are connected in series.

1 Introduction

The BaBar detector collaboration[1], installed over 200 2nd generation Resistive Plate Chambers [2] (RPCs) as part of an upgrade[3] of the forward endcap muon and neutral hadron detector (IFR) in 2002. BaBar RPCs are constructed from Bakelite treated with linseed oil and operate at 6700 V in limited streamer mode, using a gas mixture of 4.5% isobutane, 60.6% argon and 34.9% Freon-134a ($C_2H_2F_4$).

BaBar endcap chambers are built from two single gap trapezoid shaped high voltage modules joined together by vertical pickup strips and ground planes. The gas output of first module is connected to the gas input of the second

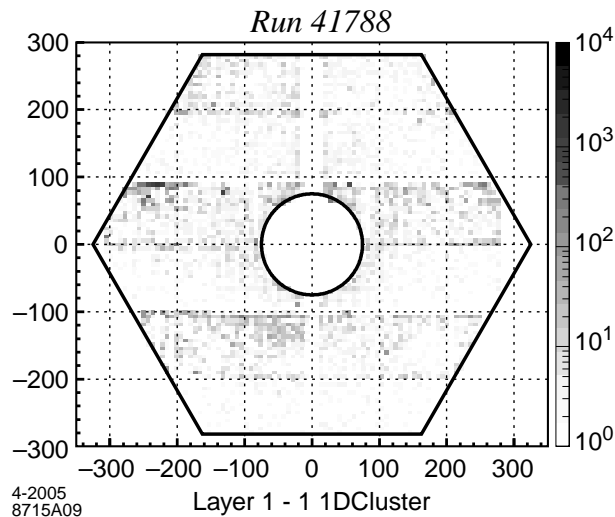


Fig. 2. RPC occupancy in Layer 1 in data collected with no beam and a random trigger.

11 module. Each endcap door was built from three such pairs as shown in Fig. 1.
 12 The HV module area varied from 1.6 m^2 (Modules 1,6), 2.1 m^2 (Modules 2,5),
 13 to 2.3 m^2 (Modules 3,4). During the first two years of operation, fresh gas
 14 flowed into the lower HV module and then to the upper HV module. The
 15 total gas volume of the chambers varies from 7 to 8 l . Gas flows were about
 16 $40 \text{ cm}^3/\text{minute}$, corresponding to a gas exchange rate of 0.3 volumes/h. Signal
 17 rates, currents, and occupancy were generally proportional to PEP-II luminos-
 18 ity with peak rates above $15 \text{ Hz}/\text{cm}^2$ in the regions closest to the beam pipe.
 19 Rates were much lower ($< 2 \text{ Hz}/\text{cm}^2$) in the top (6) and bottom (1) RPCs.

20 Early BaBar observations of RPC aging [4] suggested that pollutants pro-
 21 duced in the gas in the highest rate areas were being transported to other
 22 regions. Although the noise and background rates were symmetric about the
 23 beamline, the current and noise rates of the downstream modules increased
 24 significantly more than modules which were upstream in the gas flow. Fig. 2
 25 shows the occupancy of layer 1 due to random chamber noise. The upper mod-
 26 ule of each chamber pair has a higher density of hits than the lower module.
 27 In addition, there is a clear increase in number of noise hits in regions of high
 28 activity (around the beam-line). The clear pattern of Fig. 2 was diluted when
 29 gas flow directions were reversed and gas flows were increased after the second
 30 year. After the reversal, currents in most upper modules decreased while the
 31 currents in the lower modules (now downstream) increased.

32 Studies for ATLAS RPCs[5] suggest that both the increased noise rate and
 33 the increased ohmic part of the high voltage current could be due to the ac-
 34 tion of HF on the Bakelite surfaces inside the RPCs. HF can be produced by
 35 the breakdown of the $C_2H_2F_4$ gas component during streamer or avalanche
 36 discharges. Measurements[6] have shown that the surface conductivity of the

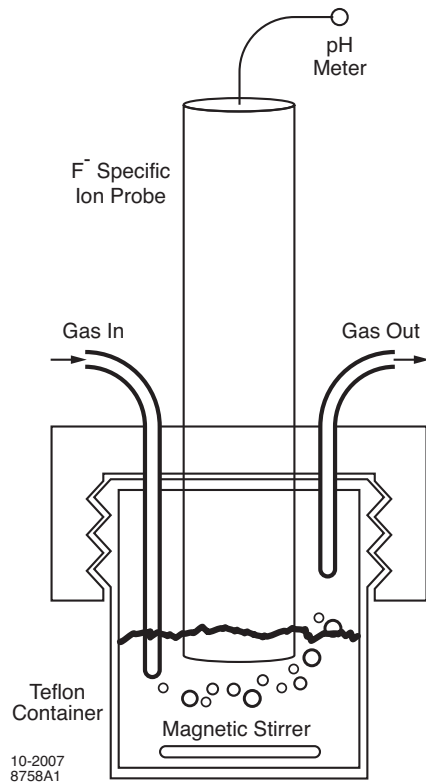


Fig. 3. Schematic view of the experimental setup for the measurement of HF concentration in the RPC exhaust gases.

37 linseed oil treated Bakelite decreases by $10^3 - 10^4$ after exposure to HF vapor.
 38 Lowered internal resistances inside the RPC high voltage structure can easily
 39 lead to significant ohmic currents that are not due to gas gain. Autopsies of
 40 original production RPCs found bumps in the linseed oil on the inner surface
 41 which were associated with regions of increased noise [3]. If HF is associated
 42 with the formation of these bumps, the mechanism could be self-sustaining,
 43 since the increased field around a bump would generate more discharges, hence
 44 more HF , which can further damage the surface. However, this proposed mech-
 45 anism is not yet supported by any direct measurement of increased HF in or
 46 near such bumps or by a detailed understanding of chemistry involved. In this
 47 paper we present measurements of the HF concentration in the exhaust gases
 48 of full size working RPC chambers.

49 2 Measurement Technique

50 The HF in the RPC exhaust gas is measured by bubbling the gas through a
 51 solution of distilled water and TISAB (Total Ionic Strength Adjusting Buffer)
 52 as shown in Fig. 3. HF contained in the gas dis-associates into H^+ and F^-

ions in the solution and is measured by a fluoride specific ion probe ². The probe is continuously immersed in the solution and connected to an acquisition system which monitors the probe output voltage as a function of time. The probe output voltage is proportional to the F^- activity which is in general less than the total ion concentration because the probe is sensitive only to dissociated F^- ions. The TISAB neutralizes the effect of electrode interfering substances such as OH^- or trace metals that could bias the measurement and acts as a buffer, keeping the solution at a constant pH of 5.5. Using the HF acid dissociation constant of $pK_a = 3.45$, the relationship between the fluoride ion concentration ($[F^-]$) and the HF concentration ($[HF]$) can be evaluated using the Henderson-Hasselbach equation [7] at this PH value:

$$pH = pK_a + \log_{10} \frac{[F^-]}{[HF]} \quad (1)$$

which gives a ratio $[HF]/[F^-] = 0.89\%$. Thus nearly all of the HF is measurable as F^- ions.

The probe has a F^- sensitivity of approximately $2\mu\text{mol/l}$ (0.05 ppm). Several baseline measurements were made to verify that the techniques employed were sensitive to HF produced in the RPCs. A measurement of fresh BaBar gas found no evidence of F^- (concentration of $< 3\mu\text{mol/l}$ after more than 1 hour of gas flow) showing that any detected F^- must have been produced in the RPC. There was about 20 m of polytetrafluoroethylene (PTFE) gas tubing between the BaBar RPCs under test and the test apparatus. To check if HF was absorbed or emitted by the tubing, fresh gas was sent through tubing which had carried the gas exhaust from a high rate RPC for more than one year of data-taking. After several hours no significant evidence of F^- in the gas was seen. Since the electrode response is sensitive to temperature changes, these measurements were performed in a temperature controlled room (20.7 ± 0.3)° C.

3 Calibration and Cross-checks

The electrode probes were periodically calibrated with solutions of known concentrations of NaF : 2.6, 5.3, 26.3, 52.6, 263, 526, 2631 $\mu\text{mol/l}$. Typical calibration curves for two probes are shown in Fig.4. Changes in the calibration response were typically slow with the most sensitive readings at very low F^- concentrations drifting by less than 5% per month.

The fraction of HF captured by the TISAB solution was measured by flowing

² Orion 96-09, Thermo Electron Corporation

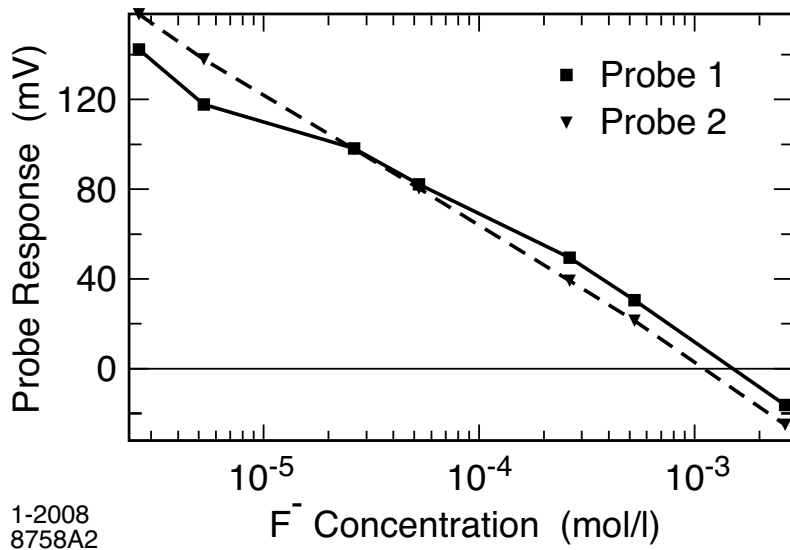


Fig. 4. Typical probe calibration curve with known concentrations of F^- in TISAB solution. Probe 1 and probe 2 are calibrated independently in two separate solutions.

87 RPC exhaust gas through two separate test setups connected in series. The
 88 output gas from the primary solution p was sent to secondary solution s . The
 89 F^- concentration was measured in both of solutions at the start (F_p^1, F_s^1) and
 90 end of the measurements (F_p^2, F_s^2). Assuming that the capture efficiency was
 91 the same for the two solutions we find that:

$$92 \quad \varepsilon = 1 - \frac{F_s^2 - F_s^1}{F_p^2 - F_p^1}. \quad (2)$$

93 From these data the HF capture efficiency was approximately 96%.

94 In the remaining part of this paper we shall assume that the F^- measured in
 95 the test solutions originate from HF in the RPC exhaust gases and quote the
 96 quantity of HF after correcting for the volume of the test solution (typically
 97 80 ml). The HF values have not been corrected for the capture inefficiency
 98 (4%) or the incomplete ionization of the HF (1%).

99 4 A Typical Measurement

100 A measurement of the exhaust gas from a layer 16 chamber, shown in Fig. 5,
 101 was performed during a period with stable PEP-II beams. This chamber, which
 102 belongs to the outermost IFR layer, had been off (no high voltage but with
 103 gas flowing) for more than one year in the previous BaBar data-taking run
 104 due to the large beam backgrounds. The first data show that no significant

105 *HF* remained in the gas. The high-voltage was ramped to 6700 V 0.8 hr after
 106 the start of the measurement. After a short delay the *HF* concentration began
 107 to rise. The *HF* concentration was measured in a 3 hour period with stable
 108 beams (time period *a*). A linear fit of this period, measured a *HF* production
 109 rate of $4.7 \times 10^{-4} \mu\text{mol/s}$. After the high-voltage was turned off, the rate of
 110 *HF* capture decreased. The capture rate was measured after one gas volume
 111 change (time period *b*), and later for a period *c* equivalent to six gas volume
 112 changes. We find that *HF* appears in the gas even well after the high-voltage
 113 had been turned off, with a rate of $3 \times 10^{-6} \mu\text{mol/s}$ nearly 1% of the peak
 114 production rate. Although not shown, the amount of *HF* in the gas remained
 measurable for a week after operation of the chamber.

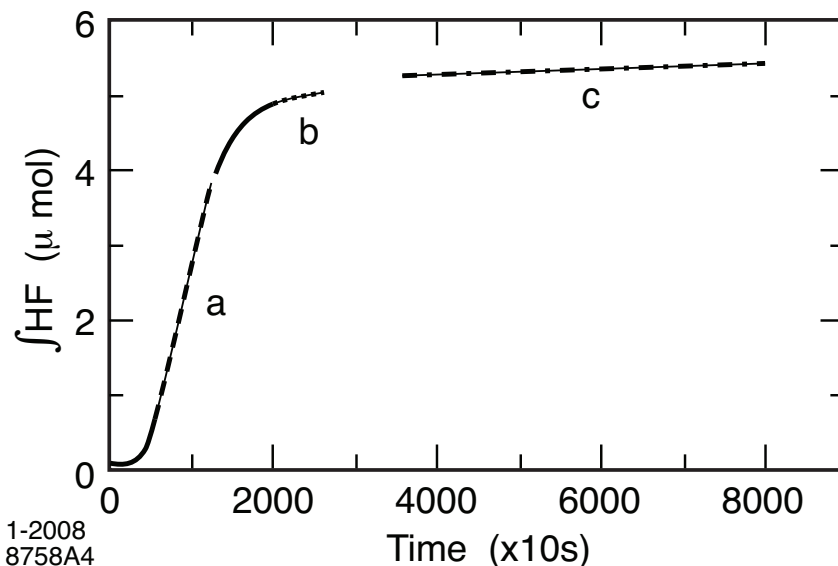


Fig. 5. Measurement of the *HF* concentration in the test solution as a function
 of time with the exhaust gas of the bottom chamber in layer 16 of the forward
 east door bubbling through the solution. Period *a* corresponds to the time period
 when the RPC was operating at 6700 Volts. Period *b* represent the change in con-
 centration measured after the high-voltage was turned off for approximately one
 volume change. The last period *c*, represents a measurement of the *HF* tail after
 the high-voltage had been off for 6 gas volume changes.

115

116 5 Correlation: *HF* vs current - Streamer RPC

117 A large number of measurements of RPCs with different operating and ambi-
 118 ent conditions were made to explore possible correlations with *HF* production.
 119 We studied the dependence of the observed *HF* rate with the high voltage
 120 current. Since only the current that passes through the gas is likely to create
 121 *HF*, we corrected the total current by subtracting off the ohmic contribution

122 (estimated by scaling the current at voltages below the gas gain turn-on). This
 123 study was made for middle chambers (modules 3 and 4 in Fig. 1) which had
 124 been operating in streamer mode since installation in 2002. Measurements of
 125 the integrated HF production in roughly 24 hour time periods were made
 126 over several months and compared to the integrated RPC current. The cur-
 127 rent was integrated from 3 hours before the start of the HF measurement to
 128 3 hours before the end of the HF measurement. This offset allowed the gas to
 129 propagate through the entire chamber before the measurement. The current
 130 varied with the PEP-II luminosity and operational status. The data is shown
 in Fig. 6. A clear correlation between the integrated current and the amount of

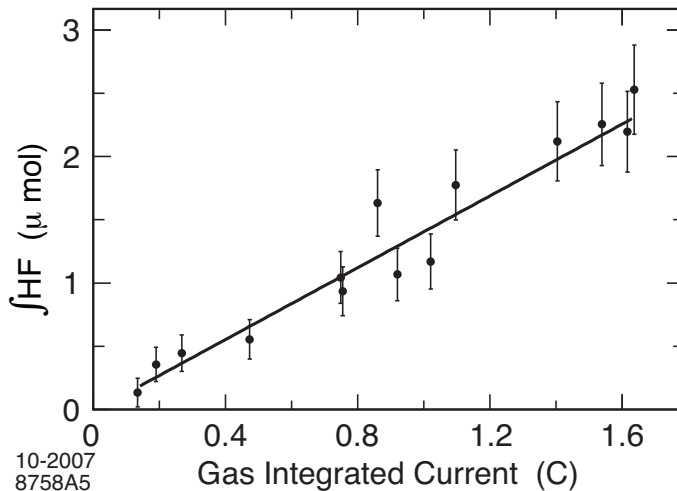


Fig. 6. Daily HF production as a function of the integrated RPC current for a RPC chamber operated in streamer mode.

131 detected HF is seen. A linear fit to the data in Fig. 6, yields a HF production
 132 rate of $1.42 \pm 0.11 \mu\text{mol}/\text{C}$ for this RPC. A second streamer mode RPC was
 133 also measured and found to have a HF production rate of $2.23 \pm 0.23 \mu\text{mol}/\text{C}$.
 134

135 6 Correlation: HF vs current - Avalanche RPCs

136 BaBar has converted several of the highest rate RPCs to avalanche mode op-
 137 eration starting in 2005. Three chambers were tested in saturated avalanche
 138 mode in 2005/6. Currently 24 RPCs have been converted to this mode. This
 139 situation allows for a comparison of HF production rates in streamer and
 140 avalanche mode. The gas mixture used for RPCs in avalanche mode is 19.4%
 141 Ar , 4.5% isobutane, 75.5% Freon-134a, 0.6% SF_6 . Preamplifiers were inserted
 142 between the RPC pick-up strips and the standard front-end electronics to
 143 compensate for lower pulse heights in avalanche mode operation. Initial per-
 144 formances have been good with higher efficiencies in the high rate ring around
 145 the beamline being demonstrated in all chambers. The average currents in the

146 RPCs converted to avalanche mode decreased by roughly a factor of four.

147 We measured the HF concentration in the exhaust gas of a middle cham-
148 ber which had been operating in avalanche mode for over six months. These
149 measurements were performed simultaneously with the measurements on the
150 neighboring streamer chamber with a second independent probe. In this way
151 the streamer and avalanche RPCs experience nearly identical background and
152 signal conditions.

153 The avalanche chambers were operated at 9800 Volts. Most of the measure-
154 ments were made at this voltage, but three measurements were made with
high-voltage lowered to 9600 V. The results are shown in Fig. 7. The HF pro-

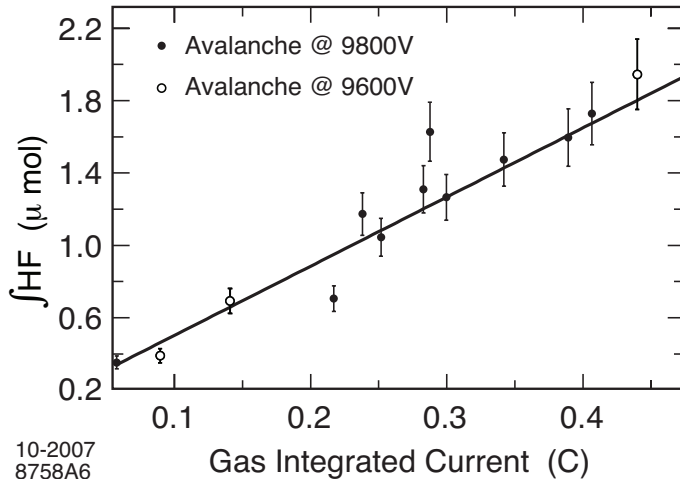


Fig. 7. Daily HF production as a function of the integrated RPC current of a middle RPC chamber operated in saturated avalanche mode. Solid dots represent measurements at the nominal operating voltage of 9800 V. Open dots represent measurements at a voltage of 9600 V. The linear fit is performed only with the nominal voltage data.

155
156 duction rate, estimated from the measurements at 9800 V only, is 3.82 ± 0.23
157 $\mu\text{mol}/\text{C}$. The rate of HF production measured on the avalanche chamber when
158 operated at 9600 V is consistent with the measurements at 9800 V. A second
159 avalanche mode RPC was measured and found to have a lower HF production
160 rate of $1.45 \pm 0.14 \mu\text{mol}/\text{C}$. These values may indicate that avalanche cham-
161 bers produce more HF per unit charge than the streamer chambers, probably
162 due to the larger Freon-134a fraction, higher voltage, and the presence of SF_6
163 in the gas mixture. However, since the HF production rate of the avalanche
164 RPCs varies by more than a factor of two, a larger sample of chambers would
165 be needed to draw firm conclusions. We can say that the average amount of
166 HF produced per track in avalanche mode is less than in streamer mode, since
167 the currents drawn by the avalanche RPCs are much less than the streamer
168 mode RPCs.

170 We checked the correlation between HF production and the average PEP-II lu-
 171 minosity as shown in Fig. 8. The streamer mode chamber in Fig. 8a has a
 172 steeper slope than the avalanche mode chamber shown in Fig. 8b consistent
 173 with the conclusions of the previous section, since the RPC currents vary lin-
 174 early with PEP-II luminosity. The streamer mode RPC produces more HF per
 175 unit of luminosity than the avalanche mode RPC. To check the consistency
 176 of the measurements done with the two electrode probes, a small number of
 177 data points were taken with the probes swapped between test solutions. No
 significant differences were seen.

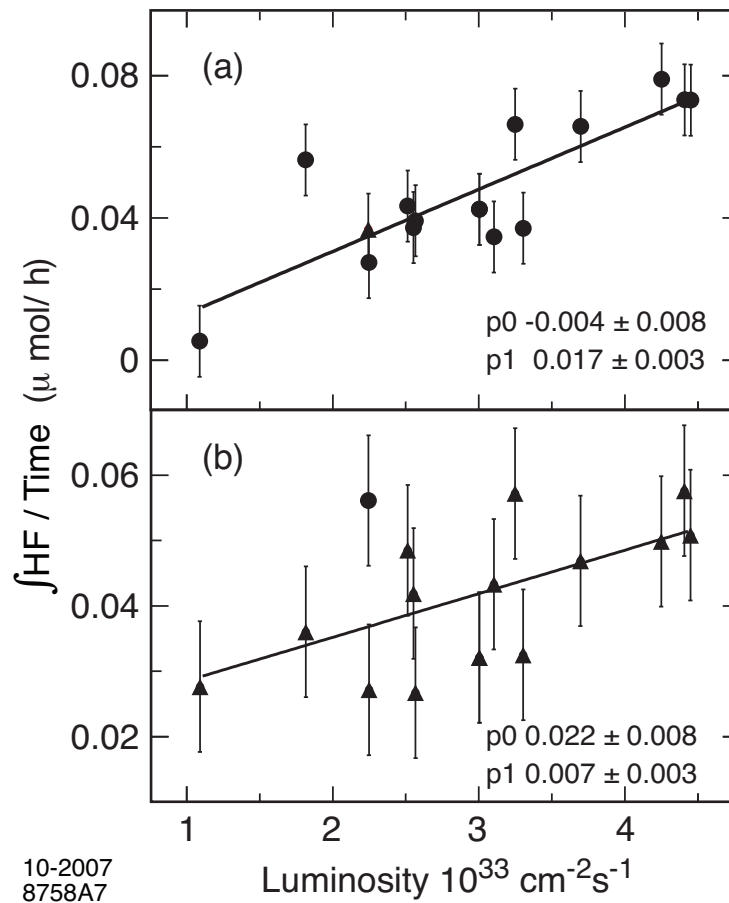


Fig. 8. Integrated HF/h as a function of the instantaneous luminosity of PEP-II for streamer chamber (a) and avalanche chamber (b). Circular dots and triangular dots represent measurements with different electrode probes.

180 The amount of *HF* in the RPC exhaust gas was measured over a three month
 181 period. To compare data with different luminosity and currents, the integrated
 182 *HF* was normalized by the RPC current. These data and the temperatures of
 183 the IR hall and endcap steel are plotted in Fig. 9. Different modules produce
 184 different amounts of *HF*. The data show more variability with time than
 185 expected from the conservatively estimated errors. No strong correlations were
 186 found between the rate of *HF* production and the temperature, hall humidity,
 187 or input gas humidity. These observations are consistent with measurements
 188 from the previous year which saw no significant change in the amount of *HF*
 189 when the input gas humidity was changed from 0% to 30% RH.

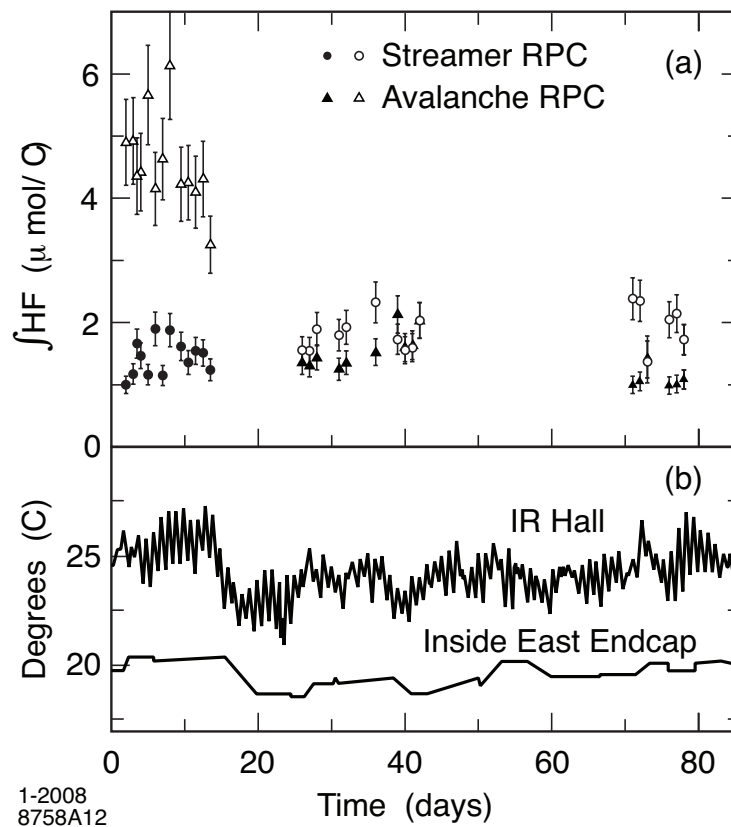


Fig. 9. Integrated *HF*/*C* for avalanche and streamer mode chambers plotted versus time in (a): Open triangles - FEM3, Solid circles - FEM2, solid triangles - FEM5, open circles - FEM7. On day 68 the avalanche gas composition was changed to 22.0% *Ar*, 4.5% isobutane, 73.0% Freon-134a, 0.6% *SF*₆ and the high voltage was lowered from 9800 V to 9500 V. The IR hall temperature and the temperature inside the forward endcap (layer 10) are plotted in (b).

191 If HF produces the aging seen in the BaBar chambers, then some fraction of
 192 the HF produced in the RPC gas must be absorbed by the inner RPC Bakelite
 193 surfaces. To test this hypothesis the HF production rate was measured in a
 194 RPC chamber having very different rates in the two high-voltage modules.
 195 The RPCs operated in streamer mode with a gas flow of about $70 \text{ cm}^3/\text{min}$.
 196 The current for the upper module (2 in the numbering scheme of Fig. 1) was
 197 $I_{top} \sim 53.2 \mu A$. The current for the lower module (1) was $I_{bottom} \sim 5.5 \mu A$.
 198 We measured the HF rate with the gas exiting from the bottom module to
 199 be $(872 \pm 24) \cdot 10^{-6} \mu\text{mol/s}$. After reversing the gas flow such that the gas
 200 exited the upper (high current module), we measured a HF rate of $(1527 \pm 42) \cdot 10^{-6} \mu\text{mol/s}$. The measurements are shown in Fig. 10. The observed HF

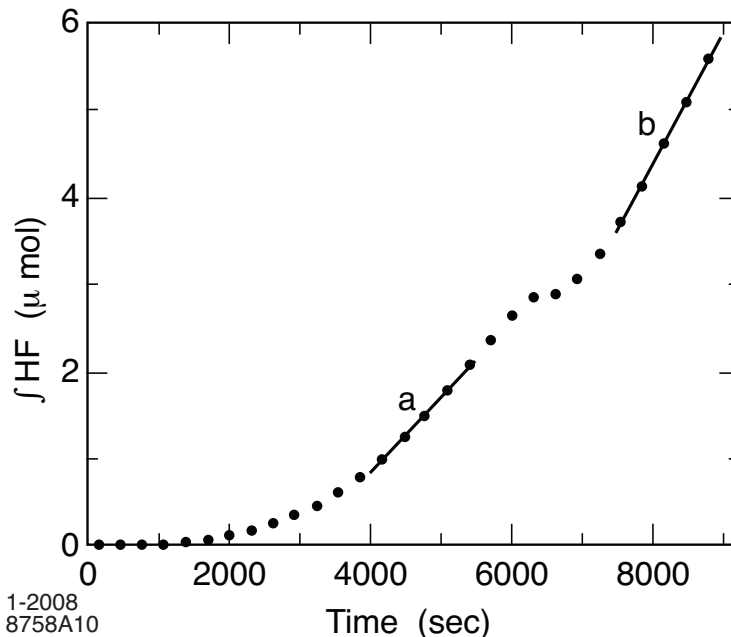


Fig. 10. Measurement of the HF rate in the exhaust gas of a chambers (whose high-voltage modules had very different noise rates) during normal gas flux (0-5500 s) and with reversed gas flux (5500-9000 s). In conditions of reversed gas flux the gas exits from the high-current module.

201 rate was significantly larger when the gas exhausts directly from the high-
 202 current module. This suggests that in the original gas flow configuration part
 203 of the HF produced in the high-current module (F_2) was absorbed by the low-
 204 current module (F_1). Considering the low-current module as a pure absorber
 205 the fraction of HF trapped can be estimated as
 206

$$207 \quad F_{abs} \simeq \frac{F_2 - F_1}{F_2} = 43 \pm 4\% \quad (3)$$

208 A more realistic analysis assumes that the fraction of HF absorbed by the
 209 Bakelite surfaces depends only on the Bakelite area. If the backgrounds uni-
 210 formly illuminate the RPC modules, then on average the HF produced in
 211 the gas is exposed to 1/2 the surface area of the chamber in which the HF
 212 is produced and 100% of the downstream module. Assuming further that the
 213 absorption rates of the two modules are the same leads to the conclusion that
 214 20% of the HF produced in the initial module is absorbed in the initial (up-
 215 stream) module and 40% is absorbed by the second (downstream) module.
 216 Both estimates show that only a fraction of the HF produced in the RPC is
 217 flushed from the chamber by the gas flow.

218 To check if HF was still present in the RPCs after the chambers have been
 219 turned off measurements were made on chambers that had been unpowered
 220 and flushed for 7 weeks with the nominal gas mixture. After that, the chambers
 221 were flushed with pure Ar gas. A residual HF signal was seen in the gas even
 222 after 7 weeks. Next, a voltage of 2300 V, producing a total current of about 100
 223 μA was applied. A much higher concentration of HF in the exhaust gas was
 224 measured, during and after having switched the high-voltage on. These data
 are shown in Fig. 11. A significant amount of HF was produced and measured

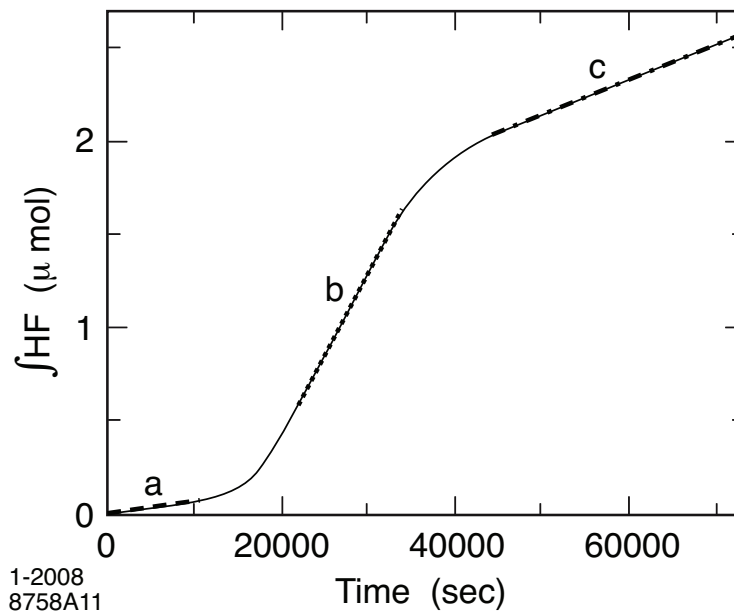


Fig. 11. Measurement of the HF rate in the exhaust gas of a middle chamber when flushed with pure Ar gas. Lines a and c represent linear fits to the intervals with no high-voltage before and after the high voltage was turned on. Line b represents the fit to the interval with 2300 V voltage.

225
 226 in exhaust gas: $(89.0 \pm 0.1) \cdot 10^{-6} \mu\text{mol/s}$. Since neither Freon-134a, nor SF_6
 227 is present in the gas mixture, the gathered HF could only be extracted from
 228 the inner surface. The extracted HF rate depends on the current drawn by
 229 the chamber. HF rate measured in pure Ar with no high-voltage is in-fact
 230 significantly reduced, as shown in Fig. 11. These data suggest that a significant

231 fraction of the HF ions trapped on the chamber surface can be removed by
232 flushing many fresh gas volumes, and/or by applying high-voltage in a pure
233 Ar gas flow.

234 10 Summary

235 In conclusion, we have studied the HF production rate in second generation
236 BaBar RPCs operating in streamer or avalanche mode. The amount of HF
237 in the exhaust gas was strongly correlated to the current and to the number of
238 tracks crossing the chamber. Less HF was measured for avalanche chambers
239 than for streamer chambers with similar efficiency and background. This im-
240 plies that we can expect that aging of the avalanche mode RPCs at the LHC
241 will be slower than that observed in the BaBar RPCs. We have not found
242 any significant correlation of the HF rate with the temperature or with the
243 relative humidity of the input gas.

244 The amount of HF decreased significantly after the RPC high voltage was
245 removed, but remained measureable for more than 200 gas volume changes.
246 More than 1/2 of the HF produced by an upstream HV module is either self-
247 absorbed or absorbed in the downstream module. When processed with Ar at
248 2300 V much of the absorbed HF can be removed from the chambers.

249 These findings are consistent with the following model of RPC aging. HF is
250 produced in the RPC gas at a rate proportional to the number of streamers
251 or avalanches. Most of the HF is absorbed by the linseed oil/Bakelite inner
252 surfaces of either the original RPC or by any RPC downstream in the gas
253 flow. The amount of HF in the HV surfaces builds up over time, reduces the
254 surface conductivity, and causes higher currents and increased noise. Flushing
255 the chambers when off reduces the amount of HF and partially reduces ob-
256 served current and noise increases. Processing with Ar can further reduce the
257 observed current and noise increases.

258 11 ACKNOWLEDGEMENTS

259 We wish to thank Giulio Aielli for his assistance in starting our HF mea-
260 surements. We would like to thank A. Zallo for his assistance in collecting
261 these measurements. We thank our PEPII colleagues for their efforts to con-
262 stantly improve luminosity and reduce detector backgrounds. This work was
263 supported by the U.S. Dept. of Energy and the I.N.F.N in Italy.

- 265 [1] BaBar Collaboration, B. Aubert *et al.*, NIMA479, 1 (2002).
- 266 [2] R. Santonico and R. Cardarelli, Nucl. Instrum. Meth. **187**, 377 (1981).
- 267 [3] F. Anulli *et al.*, “BaBar Forward Endcap Upgrade” Nucl. Instrum. Meth. A
268 **539**, 155 (2005).
- 269 [4] F. Anulli *et al.*, “Performance of 2nd generation BaBar resistive plate
270 chambers,” Nucl. Instrum. Meth. A **552**, 276 (2005).
- 271 [5] G. Aielli *et al.*, “Fluoride Production in RPCs operated with F^- compound
272 gases”, Nucl. Phys. Proc. Suppl. **158**, 143 (2006).
- 273 [6] C. Lu, “R and D on IHEP RPC ” RPC2007, Mumbai, India.
- 274 [7] L. J. Henderson, Am. J. Physiol. **21**, 173-179 (1908), K. A. Hasselbach,
275 Biochemische Zeitschrift **78**, 112-144 (1916)
- 276 [8] T. Kubo *et al.*, Nucl. Instrum. Meth. A **508**, 50 (2003).